Electronics and Trigger developments for the Diffractive Physics Proposal at 220 m LHC-ATLAS

Patrick Le Du Jean-François Genat

CEA Saclay

TWEPP Workshop, Sept. 3d-7th 2007 Prague, Czech Republic

- Diffractive Physics at LHC
- Roman Pots at ATLAS
- Silicon Detectors
- Timing using Micro-channel Plates
- Trigger and DAQ
- Conclusion

Diffractive Physics at LHC

Project to install Roman Pots detectors at 220m from the ATLAS IP

Collaboration between :

- Prague, Cracow, Saclay, Stony Brook, Giessen, Paris 6,
- Chair : Christophe Royon (DAPNIA CEA Saclay)

Physics processes

- Study of inclusive events (the only events which are existing for sure)
 - Determination of gluon at high β , search for SUSY events (or any resonance) when dijet background is known
- Exclusive Higgs:
 - Signal over background: ~ 1 if one gets a very good resolution using Roman Pots (better than 1 GeV), enhanced by a factor up to 50 for SUSY Higgs at high tan β

• QED WW pair production

- Cross section known precisely, allows to calibrate precisely the Roman Pot detectors

• Diffractive top, stop pair production

Possibility to measure top and stop masses by performing a threshold scan with a precision better than 1 GeV if cross section high enough

RP220 vs. other projects

- High Luminosity
- Additional signal and flag at the L1 ATLAS Trigger
- Natural follow-up of the ATLAS luminosity project at 240 m to measure total cross section
- Complementary to the RP420 (Roman Pots at 420m)

- Diffractive Physics at LHC
- Roman Pots at ATLAS
- Silicon Detectors
- Timing using Micro-channel Plates
- Trigger and DAQ
- Conclusion



Two horizontal pots at 216 and 224 m on each arm with detectors as close as possible to the beam: 10 σ = $1\mu m$



Roman Pot Layout



- Diffractive Physics at LHC
- Roman Pots at ATLAS
- Silicon Detectors
- Timing using Micro-channel Plates
- Trigger and DAQ
- Conclusion

Silicon detectors

One Roman Pot:

-

Five Silicon strips detectors :

- $25 \,\mu\text{m}$ pitch detector of 2.54cm x 2.54cm,
- 1000 channels, 10-bit address.
- **2X**, **1Y**, **1U**, **1V** detectors
 - Two of them used for L1 trigger.



P. Le Du, J-F Genat, TWEPP Workshop, Sept. 3d-7th 2007 Prague.

Roman pots specific requirements

- Achieve 10 μ m position resolution: 50 μ m pitch strips read in digital :

 $25 / \sqrt{12} = 14.4 \,\mu\text{m}$ resolution

- Edgeless:

Collect edge currents through the bulk to allow full depletion, or avoid them.

TOTEM:

- Rings biased at the strip potential as close as possible to the edge, collect currents due to cut, allow to be sensitive down to 20 - 50 μm



Proposed by Canberra: edge equipotential, no more edge current flowing.

Detectors specifications

Size **AC** coupled Interstrip **Full depletion** Thickness Leakage current **Resistance poly (one side)** Interstrip resistance Pads AC and DC **Edgeless on one side** Pitch Pitch adapters to 100 μ m on detector (four rows) **Defective strips**

2.54 x 2.54 mm² >10pF/cm, insulated to >300V < 1.5 pF/cm 60-100V 300 µm +/- 20 mm 50nA/cm² at 300V bias 1.5+/-.5 MΩ $> 2 G \Omega$

< 30 μm

25 µm

<1%

Quantities: 20 + 12 spares = 32

Availability from the industry

TOTEM: CERN and IOFFE PTI (Russia) produce edgeless first detectors moved to INTAS-CERN EU project.

Companies contacted:

- Canberra (AREVA Belgium)
- Hamamatsu
- Sintef (Norway)
- VTT (Finland)
- Canberra started small prototypes 6.4 x 6.4 mm, 50 μ m pitch, DC coupled, edgeless at 25 and 50 μ m, available for tests beg 2007.
- Hamamatsu and Sintef made also offers.

VTTclaims to be able to do edgeless to 20 μ m. Semi-3D availability

Test detectors



Detectors tested for reverse current at FZU Prague

Presently wire-bonded to ATLAS SCT hybrids at CERN Mirek Hravana



CANBERRA 50 μ m pitch test detectors

Tests at FZU Prague (July 2007)



Reverse current measurement depending on the strip position typically 25 nA OK. Further tests need a full detector wire-bonded and biased.

Breakdown voltage 110-130 V OK

Test stand at Saclay

CERN provided a test stand with hybrids equipped with regular ABCDs chips used for the ATLAS SCT Thanks to Shaun Roe and Francis Anghinolfi

Future ABCD chip will include fast outputs (W.Dabrowski)

VME readout module driven by a PC installed at Saclay

• Diffractive Physics at LHC

- Roman Pots at ATLAS
- Silicon Detectors
- Timing using Micro-channel Plates
- Trigger and DAQ
- Conclusion

Micro-Channel Plates Timing Detectors

• Used to achieve picosecond coincidences and reconstruct Vertex to 1mm precision

Burle-Photonis provides MCP detectors

8 x 8 segmented anodes readout

Major advances for TOF measurements



Micro-photograph of Burle 25 µm pores tube Greg Sellberg (Fermilab) Now 10 µm pores 2" x 2" sensitive area

Courtesy: Henry Frisch Univ Chicago

MCP PMT single photon signals



Electronics developed at Univ. Chicago

See Poster by Fukun Tang (this Workshop)

- Two cards 2" x 2" connected to the MCP anode planes

Picosecond card with picosecond Time stretcher SiGe chip includes:

- Discriminator
- 2 GHz PLL
- Time stretcher

FPGA card includes

- 200ps TDC
- Control, calibration, interface

- Diffractive Physics at LHC
- Roman Pots at ATLAS
- Silicon Detectors
- Timing using Micro-channel Plates
- Trigger and DAQ
- Conclusion







Timing and Data flow



Implementation block diagram



- Diffractive Physics at LHC
- Roman Pots at ATLAS
- Silicon Detectors
- Timing using Micro-channel Plates
- Trigger and DAQ
- Conclusion

Conclusion

Much work to be completed timely Not too many people...

- Detectors Silicon, MCP
- Electronics SiGe-CMOS chips, FPGAs
- System Insertion into ATLAS L1 and DAQ Micro TCA foreseen
- Install...

backup

3D detectors vs Planar



Cinzia Da Via (FP440), Brunel, UK 11/2004 Stanford, SINTEF, VTT

Edge processing

- "Precise" diamond saw VS dry etching
- A fraction of this production will be sent to the CNM of Barcelona for the dicing with dry etching Dry etching Diamond saw (CNM Barcelona)



 If this test is satisfactory (in terms of yield and performance) we could still adopt this technique for the mass production

Gennaro Ruggiero (TOTEM)

Micrometer range cut uniformity allows low edge surface currents.